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Attorney Docket No. UMC-96-279 CON
Client Matter No. 81848.0016.001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Patent Application of:

Chih-Chien LIU, et al.

Serial No. 09/546,174

Filed: April 11, 2000

For: HIGH DENSITY PLASMA
CHEMICAL VAPOR
DEPOSITION PROCESS

Art Unit: 1711

Examiner: Rabon A. SERGENT

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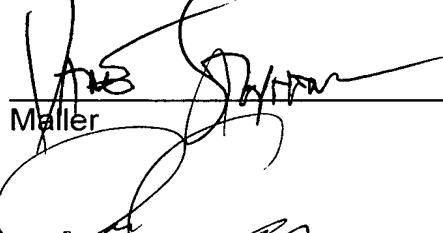
Sir:

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INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. 1.97

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant hereby submits for filing under 37 CFR 1.97 a disclosure statement. In submitting these references, no representation is made or implied that the references are or are not material to the examination of this application. The patents, publications or other information of which Applicant is presently aware are listed in Form PTO/SB/08A submitted herewith and copies of all such patents and publications are attached hereto.

This Information Disclosure Statement is being filed pursuant to 37 CFR 1.97(c). A check to cover the fee set forth in 1.17(p) is enclosed herewith. Any fee deficiency associated with this submittal may be charged to Deposit Account No. 50-1123.

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Signed on February 10, 2003.

Respectfully submitted,

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